	Application No.	Applicant(s)
Notice of Allowability		
	09/715,973	ANNAPRAGADA, RAO V.
	Examiner	Art Unit
	Lourdes C. Cruz	2827
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. This communication is responsive to An Amendment filed	06-10-03.	
2. The allowed claim(s) is/are 21-27 and 36-45.		
3. The drawings filed on are accepted by the Examine	r.	
 4. ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) ☐ All b) ☐ Some* c) ☐ None of the: 		
 Certified copies of the priority documents have been received. 		
2. Certified copies of the priority documents have been received in Application No		
3. Copies of the certified copies of the priority documents have been received in this national stage application from the		
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
5. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).		
(a) The translation of the foreign language provisional application has been received.		
6. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE 7. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF		
INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.		
 8. ☐ CORRECTED DRAWINGS must be submitted. (a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) ☐ hereto or 2) ☐ to Paper No (b) ☐ including changes required by the proposed drawing correction filed <u>17 September 2002</u>, which has been approved by the 		
Examiner.		
(c) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No		
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet.		
9. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.		
Attachment(s)		
 Notice of References Cited (PTO-892) Notice of Draftperson's Patent Drawing Review (PTO-948) Information Disclosure Statements (PTO-1449), Paper No Examiner's Comment Regarding Requirement for Deposit of Biological Material 	4⊡ Interview Summ 6⊡ Examiner's Ame	al Patent Application (PTO-152) ary (PTO-413), Paper No endment/Comment ement of Reasons for Allowance

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DETAILED ACTION

Allowable Subject Matter

The following is an examiner's statement of reasons for allowance: There is prior art regarding conductive patterns (first conductive pattern element) having a via hole defining a path to the pattern element, a wall surface on the via hole covered by a material, a substrate, a TiN layer, a fill material in the via, and a second conductive element. See, for example, that Matsuura (US 6034418) discloses all the above structural limitations.

However, see that the claims as presented clearly recite a hydrophobic material. The term hydrophobic, as presented by Applicant and as defined in the specification has been given patentable weight for it clearly describes (see, for example page 5 of the disclosure) a material (an inner wall surface layer) in a semiconductor device via structure that prevents moisture absorption (as a result of performing a chemical dehydroxylation). Halogen atoms bonded to silicon atoms are the resulting layer in the device claimed. This hydrophobic layer containing halogen atoms (as described by Applicant, see above) is the very specific structure to which the examiner refers in the notice of allowance found herein.

The above hydrophobic layer as described by the Applicant, and as discussed above, in combination with all other very specific limitations in the claims is neither obvious over nor anticipated by the prior art of record, which fails to either alone or in combination anticipate the device as presented in the Application. Hence the notice of allowability found herein.

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Any comments considered necessary by applicant must be submitted no later

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than the payment of the issue fee and, to avoid processing delays, should preferably

accompany the issue fee. Such submissions should be clearly labeled "Comments on

Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Elle Cruz whose telephone number is 703-306-5691.

The examiner can normally be reached on M-F 10-6:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, David L. Talbott can be reached on 703-305-9883. The fax phone numbers

for the organization where this application or proceeding is assigned are 703-308-7722

for regular communications and 703-308-7722 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or

proceeding should be directed to the receptionist whose telephone number is 703-308-

0956.

Lourdes C. Cruz Examiner

Art Unit 2827

Élle Cruz June 29, 2003

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